



TFC 1723
PATENT APPLICATION

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant : Mikio SUGIMOTO

: MANUFACTURING METHOD OF METAL ION WATER,
WATER TREATMENT METHOD USING THE MANUFACTURING METHOD,
MANUFACTURING DEVICE OF METAL ION WATER, AND
WATER TREATMENT APPARATUS USING THE MANUFACTURING DEVICE

Serial No.: 10/567 707 Group: 1723

Confirmation No.: 3892

Filed : February 7, 2006 Examiner: Unknown

International Application No.: PCT/JP2004/011721

International Filing Date : August 9, 2004

Atty. Docket No.: 4900.P0056US

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

FIRST CLASS MAILING CERTIFICATE

Sir:

I hereby certify that this correspondence is being deposited with the United States Postal Service under 37 CFR 1.8 as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on September 11, 2006.

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Correspondence: Letter to Patent Office
dated September 11, 2006
including enclosures listed thereon

190.05/05

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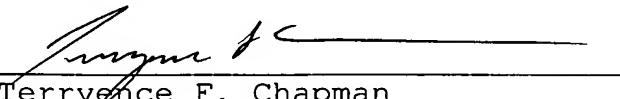
Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

LETTER TO PATENT OFFICE

Sir:

Enclosed herewith is a Supplemental Oath or Declaration for the present application in which the correct foreign priority information for the present application is contained therein. Also enclosed herewith are certified copies of the foreign priority applications. Favorable consideration is respectfully solicited.

Respectfully submitted,


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Encl: Supplemental Declaration (1)
 Certified copies of Foreign Priority Documents (4)
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